

Title (en)

COMPLEX MICRODEVICES AND APPPARATUS AND METHODS FOR FABRICATING SUCH DEVICES

Title (de)

KOMPLEXE MIKROEINRICHTUNGEN UND VORRICHTUNGEN UND VERFAHREN ZUR HERSTELLUNG SOLCHER EINRICHTUNGEN

Title (fr)

MICRODISPOSITIFS COMPLEXES, APPAREIL ET PROCEDES DE FABRICATION DE CEUX-CI

Publication

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Application

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- US 34037201 P 20011206
- US 36426102 P 20020313
- US 37913302 P 20020507
- US 37918402 P 20020507
- US 37913502 P 20020507
- US 37917702 P 20020507
- US 37918202 P 20020507
- US 37913002 P 20020507
- US 39253102 P 20020627
- US 41537402 P 20021001
- US 41537102 P 20021001
- US 42200702 P 20021029
- US 42298202 P 20021101
- US 42948302 P 20021126
- US 42948402 P 20021126
- US 43080902 P 20021203
- US 30952102 A 20021203

Abstract (en)

[origin: WO03050852A2] Various embodiments of the invention are directed to various microdevices including sensors, actuators, valves, scanning mirrors, accelerometers, switches, and the like. In some embodiments the devices are formed via electrochemical fabrication EFAB TM

[origin: WO03050852A2] Various embodiments of the invention are directed to various microdevices including sensors, actuators, valves, scanning mirrors, accelerometers, switches, and the like. In some embodiments the devices are formed via electrochemical fabrication (EFAB <sp>TM</sp>)

IPC 1-7

**H01L 21/00**

IPC 8 full level

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Citation (search report)

See references of WO 03050852A2

Citation (examination)

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